



PATENT  
Attorney Docket No. 01-099  
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# 3/4  
7/6/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Rongxiang Hu, Philippe Schoenborn,) )  
and Masaichi Eda ) )  
Serial No. 09/928,570 ) )  
Filed: August 13, 2001 ) )  
For: HIGH SELECTIVELY SiC ETCH ) )  
IN INTEGRATED CIRCUIT ) )  
FABRICATION ) )

Group Art Unit: 1765  
Confirmation No. 7873  
Examiner: L. Umez-Eronini

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JUL 07 2003  
GROUP 1700

AMENDMENT AND RESPONSE TO FIRST OFFICE ACTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 31, 2003, please amend the application as set forth below in the Two Parts of this Amendment and Response.

IN THE CLAIMS:

Amend claims 1-6 and 8-11.

Part 1 hereof presents the claims with markings to indicate the changes.

REMARKS

Part 2 comments on the above amendments, and the March 31, 2003 office action.